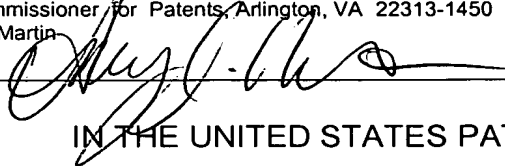


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Amy J. Martin



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Amon et al.

Group Art Unit: Not Assigned

Serial No.: Not Assigned

Examiner: Not Assigned

Filed: Herewith

Docket No.: 1406/177

For: METHOD FOR FABRICATING A SEMICONDUCTOR STRUCTURE

PRELIMINARY AMENDMENT

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Arlington, Virginia 22313-1450

Dear Sir:

Kindly amend the subject application as follows:

IN THE SPECIFICATION:

Please insert the paragraph heading on page 1 of the subject application, line 4, as follows:

--Technical Field--.

Please insert the paragraph heading on page 1 of the subject application, line 10, as follows:

--Background Art--.

Please insert the paragraph heading on page 5 of the subject application, line 17, as follows:

--Summary of the Invention--.

Please insert the paragraph heading on page 10 of the subject application, line 16, as follows:

--Brief Description of the Drawings--.

Please insert the paragraph heading on page 11 of the subject application, line 3, as follows:

--Detailed Description of the Invention--.